

## Japan TC Chapter of Automation Technology Global Technical Committee Meeting Summary and Minutes

Japan Standards Summer 2015 Meetings  
Wednesday, June 24 2015, 9:30 a.m. – 11:00 p.m.  
SEMI Japan office, Tokyo, Japan

### Next Committee Meeting

13:30-15:30 September 30, <Japan Standard Time>  
SEMI Japan, Tokyo, Japan

### Committee Announcements (optional)

None

### Table 1 Meeting Attendees

*Italics indicates virtual participants*

**Co-Chairs:** Makoto Ishikawa (Nisshinbo Mechatronics), Teruaki Ito (Mitsubishi Electric), Terry Asakawa (Tokyo Electron)

**SEMI Staff:** Junko Collins (SEMI Japan)

**Attendee:** 7 + **SEMI:** 1

<i>Company</i>	<i>Last</i>	<i>First</i>	<i>Company</i>	<i>Last</i>	<i>First</i>
Nisshinbo Mechatronics	Ishikawa	Makoto	Tokyo Electron	Murata	Naoko
Tokyo Electron	Asakawa	Terry	Siemens	Ohbuchi	Fumiyasu
Mitsubishi Electric	Yutani	Takashi	Mitsubishi Electric	Yagi	Takahiro
Mitsubishi Electric	Ito	Teruaki	SEMI Japan	Collins	Junko

### Table 2 Leadership Changes

New TC Chapter Chair: Teruaki Ito (Mitsubishi Electric)  
Stepped down TC Chapter Chair: Ken Sambu (Mitsubishi Electric)

### Table 3 Ballot Results (or move to Section 4, Ballot Review)

None

### Table 4 Authorized Ballots (or move to Section 7, New Business)

None

### Table 5 Authorized Activities (or move to Section 7, New Business)

None

### Table 6 New Action Items (or move to Section 8, Action Item Review)

None

### Table 7 Open Actions Items (or move to Section 8, Action item Review)

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
20140729-2:	Japan members of Global EIS TF	To review the SNARF # 5222 → OPEN

## 1 Welcome, Reminders, and Introductions

Makoto Ishikawa (Nisshinbo Mechatronics), co-chair, called the meeting to order at 9:30 a.m. The meeting reminders on antitrust issues, intellectual property issues and holding meetings with international attendance were reviewed by SEMI Staff. Attendees introduced themselves.

**Attachment:** Required\_Elements\_Reg\_20150327\_E+J

## 2 Review of Previous Meeting Minutes

The committee reviewed the minutes of the previous meeting.

<b>Motion:</b>	To approve the previous meeting minutes written as it is.
<b>By / 2<sup>nd</sup>:</b>	Naoko Murata (Tokyo Electron) / Terry Asakawa (Tokyo Electron)
<b>Discussion:</b>	None
<b>Vote:</b>	6 in favor and 0 opposed. <b>Motion Passed.</b>

## 3 Liaison Reports

### 3.1 Europe TC Chapter

Junko Collins (SEMI Japan) reported that Automation Technology TC Chapter in Europe is still on Standby. No special topic to be reported for this meeting. See the meeting schedule during SEMICON Europa.

**Attachment:** SCEU2015\_StandardsSchedule V2

## 4 SEMI Staff Report

Junko Collins (SEMI Japan) gave the SEMI Staff Report as attached materials. Of note:

- Global SEMI Events
- Global Standards Meetings Schedule
- Ballot Critical Dates
- New Regulations and Procedure guide
- Contact Information

**Attachment:** SEMI Staff Report 2015 June R0.2

## 5 Ballot Review

None

## 6 Subcommittee & Task Force Reports

### 6.1 Equipment Interface Specification (EIS) Task Force

No special report for this meeting

**Attachment:** no attachment

## 7 Old Business

### 7.1 Replacement of Chair Person

7.1.1 Ken Sambu stepped down from the chair position and Teruaki Ito succeeded his position

## 8 New Business

### 8.1 TC Chapter Project

- Three-year project period

Members reviewed the list. Doc. 5222 has been approved to expend the period one more year at the meeting on Dec. 9, 2014. So, no action was needed at this meeting.

**Attachment:** 150623\_Japan\_All-Committee-SNARF\_List (AT)

- 5-year review

Members reviewed the list. No action was needed at this meeting.

**Attachment:** 150604\_All-Committee\_Document-List (AT)

- Document Category issue

Prefix PV blocks to promote implementation of AT TC related SEMI Standards to industries.

<b>Motion</b>	To request SEMI to change document category from PV to AT regarding Automation Technology Technical Committee related Standards.
<b>By / 2<sup>nd</sup>:</b>	Fumiyasu Ohbuchi (SEMENS) / Takashi Yutani (Mitsubishi Electric)
<b>Discussion:</b>	None
<b>Vote:</b>	6 in favor and 0 opposed. <b>Motion Passed.</b>

**Action Item** Staff to confirm required process to change prefix of SEMI Standards and take an action

If required, TC Chapter to request ISC to change prefix from PV to AT regarding Automation Technology Technical Committee related Standards.

## 9 Action Item Review

### 9.1 Open Action Items

Junko Collins (SEMI Japan) reviewed the open action item. This can be found in the Open Action Items table at the beginning of these minutes.

20140729-2 is still open.

Item #	Assigned to	Details
20140729-2:	Japan members of Global EIS TF	To review the SNARF # 5222 → OPEN

## 9.2 New Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
20150624-1	Junko Collins	To report new co-chair to JRSC
20150624-2	Junko Collins	To confirm required process to change prefix of SEMI Standards and take an action If required, TC Chapter to request ISC to change prefix from PV to AT regarding Automation Technology Technical Committee related Standards.

## 10 Next Meeting and Adjournment

The next meeting of the Japan TC Chapter of Automation Technology Global Technical Committee is scheduled for 1:30 p.m. – 3:30 p.m., Wednesday, September 30 at SEMI Japan office in Tokyo.

The meeting was adjured at 11:00

Respectfully submitted by:  
Junko Collins  
Director, Standards & EHS  
SEMI Japan  
Phone: +81.3.3222.5819  
Email: jcollins@semi.org

Minutes approved by:

<Makoto Ishikawa> (Nisshinbo Mechatronics), Co-chair	**
<Terry Asakawa> (Tokyo Electron), Co-chair	Terry Asakawa
<Teruaki Ito>(Mitsubishi Electric), Co-chair	Teruaki Ito

**Table 8 Index of Available Attachments #1**

<i>Title</i>	<i>Title</i>
Required_Elements_Reg_20150327_E+J	SCEU2015_StandardsSchedule V2
SEMI Staff Report 2015 June R0.2	150623_Japan_All-Committee-SNARF_List (AT)
150604_All-Committee_Document-List (AT)	

#1 Due to file size and delivery issues, attachments must be downloaded separately. A .zip file containing all attachments for these minutes is available at [www.semi.org](http://www.semi.org). For additional information or to obtain individual attachments, please contact Junko Collins at the contact information above.